

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: B. Kim et al.

Attorney Docket No.: SEMT119849

Application No.: 10/700,782

Art Unit: 1753 / Confirmation No: 5493

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Examiner: E. Wong

Title: BATH AND METHOD FOR HIGH RATE COPPER DEPOSITION

AMENDMENT AFTER NON-FINAL REJECTION

Seattle, Washington 98101

October 25, 2007

TO THE COMMISSIONER FOR PATENTS:

INTRODUCTORY COMMENTS

In response to the non-final Office Action mailed April 25, 2007, applicants submit the following amendments and remarks.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of the claims, which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.

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